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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

YOSHIHIRO ISHIDA ET AL.

Application No.: 09/164,624

Filed: October 1, 1998

For: MONITORING SYSTEM
APPARATUS AND PROCESSING
METHOD

Examiner: Lin Ye

Group Art Unit: 2612

Confirmation No.: 6892

May 10, 2004

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Technology Center 2600

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed, together with a copy of a Japanese Official Action citing them, and a translation of that Action.

For the concise explanation of relevance for the non-English documents, the Examiner is referred to the accompanying English abstracts.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

May 10, 2004
(Date of Deposit)

CARL B. WISCHHUSEN (Reg. No. 43,279)
(Name of Attorney for Applicant)

Signature

May 10, 2004
Date of Signature

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